

PATENT 941-306P

IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicants:

Shun-An CHEN et al.

Conf.:

1826

Serial No.:

09/930,971

Art Unit: 2863

Filed:

August 17, 2001

Examiner: X. Sun

For:

SYSTEM FOR DYNAMICALLY MONITORING THE STABILITY

OF SEMICONDUCTOR MANUFACTURING EQUIPMENT

LARGE-ENTITY TRANSMITTAL FORM

Commissioner for Patents P. O. Box 1450 Alexandria, VA 22313-1450

September

RECEIVED

Sir:

Transmitted herewith is a REQUEST FOR RECONSIDERATION in the sabove-identified application.

The	enclosed	l document	is	being	transı	mitted	via	the	Certificate
of 1	Mailing p	provisions	of	37 C.	F.R.	§1.8.			

The enclosed document is being transmitted via facsimile.

The fee has been calculated as shown below:

	CLAIMS REMAINING AFTER AMENDMENT		HIGHEST NUMBER PREVIOUSLY PAID FOR		PRESENT EXTRA	RATE	ADDITIONAL FEE
TOTAL	13	- 20		=	0	\$ 18	\$0.00
INDEPENDENT	1	_	3	=	0	\$ 84	\$0.00
FIRST PRESENTATION OF A MULTIPLE DEPENDENT CLAIM						\$280	\$0.00
· · · · · · · · · · · · · · · · · · ·						TOTAL	\$0.00

Serial No. 09/930,971 Docket No. 941-306P

	Petition for () month(s) extension of time pursuant to 37 C.F.R. §§1.17 and 1.136(a). \$0.00 for the extension of time.
\boxtimes	No fee is required.
	Check(s) in the amount of \$0.00 is(are) enclosed.
	Please charge Deposit Account No. 02-2448 in the amount of \$0.00. This form is submitted in triplicate.

If necessary, the Commissioner is hereby authorized in this, concurrent, and future replies to debit Deposit Account No. 02-2448 for any additional fee required under 37 C.F.R. §1.16 or §1.17, particularly extension of time fees, or to credit said Deposit Account for any overpayment of fees.

Respectfully submitted,

BIRCH, STEWART, KOLASCH & BIRCH, LLP

By A Chuney I'm

Reg. No. 32,334

941-306P Attachment

KM:rk

P. O. Box 747

Falls Church, VA 22040-0747

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REQUEST FOR RECONSIDERATION

Assistant Commissioner for Patents Washington, DC 20231

September 16, 2003

Sir:

In response to the Office Action mailed June 16, 2003 (Paper No. 9), the following remarks are respectfully submitted in connection with the above-identified application:

SEP 22 2003
TECHHOLOGY CENTER 2800